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Terms	Documents
L4 and peroxide	3

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Search:

L5

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DATE: Tuesday, November 26, 2002 [Printable Copy](#) [Create Case](#)

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Query

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result set

DB=USPT,PGPB,JPAB,EPAB,DWPI,TDBD; PLUR=YES; OP=ADJ

L5	L4 and peroxide	3	L5
L4	L3 and wetting and wiring	3	L4
L3	L2 and (porous near5 (silicon or oxide))	47	L3
L2	L1 and (pad section or bonding pad)	3538	L2
L1	((438/\$)!.CCLS.)	131400	L1

END OF SEARCH HISTORY

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Terms	Documents
L3 and wetting and wiring	3

Database:

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Search:

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result set*DB=USPT,PGPB,JPAB,EPAB,DWPI,TDBD; PLUR=YES; OP=ADJ*

<u>L4</u>	L3 and wetting and wiring	3	<u>L4</u>
<u>L3</u>	L2 and (porous near5 (silicon or oxide))	47	<u>L3</u>
<u>L2</u>	L1 and (pad section or bonding pad)	3538	<u>L2</u>
<u>L1</u>	((438/\$)!.CCLS.)	131400	<u>L1</u>

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L4: Entry 1 of 3

File: PGPB

Oct 25, 2001

PGPUB-DOCUMENT-NUMBER: 20010033028
PGPUB-FILING-TYPE: new
DOCUMENT-IDENTIFIER: US 20010033028 A1

TITLE: Semiconductor devices and methods for manufacturing the same

PUBLICATION-DATE: October 25, 2001

INVENTOR-INFORMATION:

NAME	CITY	STATE	COUNTRY	RULE-47
Matsumoto, Kazumi	Chino-shi		JP	
Morozumi, Yukio	Chino-shi		JP	
Asahina, Michio	Sakata-shi		JP	

US-CL-CURRENT: 257/765; 257/779, 438/612, 438/783, 438/787, 438/790, 438/960

Full	Title	Citation	Front	Review	Classification	Date	Reference	Sequences	Attachments	Claims	KWMC
Draw	Desc	Image									

☐ 2. Document ID: US 6287948 B1

L4: Entry 2 of 3

File: USPT

Sep 11, 2001

US-PAT-NO: 6287948
DOCUMENT-IDENTIFIER: US 6287948 B1

TITLE: Semiconductor device and method for making pattern data

DATE-ISSUED: September 11, 2001

INVENTOR-INFORMATION:

NAME	CITY	STATE	ZIP CODE	COUNTRY
Ushiyama, Fumiaki	Fujimi-machi			JP

US-CL-CURRENT: 438/606; 257/296, 257/306, 257/572, 257/578, 257/773, 438/241, 438/462, 438/599, 438/622, 438/926

Full	Title	Citation	Front	Review	Classification	Date	Reference	Sequences	Attachments	Claims	KWMC
Draw	Desc	Image									

☐ 3. Document ID: US 6245659 B1

L4: Entry 3 of 3

File: USPT

Jun 12, 2001

US-PAT-NO: 6245659

DOCUMENT-IDENTIFIER: US 6245659 B1

TITLE: Semiconductor device and method for manufacturing the same

DATE-ISSUED: June 12, 2001

INVENTOR-INFORMATION:

NAME	CITY	STATE	ZIP CODE	COUNTRY
Ushiyama; Fumiaki	Fujimi-machi			JP

US-CL-CURRENT: 438/620; 438/622, 438/623, 438/624, 438/625, 438/627, 438/638, 438/668

Full	Title	Citation	Front	Review	Classification	Date	Reference	Sequences	Attachments
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L3 and wetting and wiring

Documents

3

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